

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention

IMPROVED CD UNIFORMITY OF CHROME ETCH TO
PHOTOMASK PROCESS

Application Number : 10/605,801

Confirmation Number:

First Named Applicant: Shaun Crawford

Attorney Docket Number: BUR920030104US1

Art Unit: 1756

Examiner: Young

Search string: (6544894 or 5185058 or 5010378 or 4916511 or 4690729 or 4659426 or 5837615
) .pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
|------|----------|------------|------------|---------------|------|-------|----------|
| Cy | 1 | 6544894 | 2003-04-08 | Kobayashi | | 438 | 706 |
| Cy | 2 | 5185058 | 1993-02-09 | Cathey, Jr. | | — | — |
| Cy | 3 | 5010378 | 1991-04-23 | Douglas | | — | — |
| Cy | 4 | 4916511 | 1990-04-10 | Douglas | | — | — |
| Cy | 5 | 4690729 | 1987-09-01 | Douglas | | — | — |
| | 6 | 4659426 | 1987-04-21 | Fuller et al. | | — | — |
| Cy | 7 | 5837615 | 1998-11-17 | Rostoker | | 438 | 711 |

Signature

| Examiner Name | Date |
|---------------|--------|
| Chen J. Young | 2/2005 |